



1763
H/1
PATENT
3/21/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: BAILEY III et al.

Attorney Docket No.: LAM1P124D1

Application No.: 09/943,806

Examiner: Alejandro Mulero, Luz L

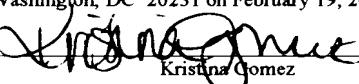
Filed: August 30, 2001

Group: 1763

Title: TEMPERATURE CONTROL SYSTEM
FOR PLASMA PROCESSING APPARATUS

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, Washington, DC 20231 on February 19, 2002.

Signed: 

Kristina Gomez

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

In response to the Restriction Requirement dated January 23, 2002, Applicant elects to prosecute Group II, claims 23-27. However, it should be noted that claims 1-22 and 28-31 were cancelled from the application upon filing.

If any fees are due in connection with the filing this Response to Restriction Requirement, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. LAM1P124D1).

Respectfully submitted,
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